



PATENT

Case Docket No. ASMEEX.291A

Date: May 8, 2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Todd et al.
Appl. No. : 10/074,563
Filed : February 11, 2002
For : IMPROVED PROCESS FOR
DEPOSITION OF
SEMICONDUCTOR FILMS
Examiner : Unassigned
Group Art Unit : 1762

I hereby certify that this correspondence and all marked
attachments are being deposited with the United States
Postal Service as first class mail in an envelope addressed
to: United States Patent and Trademark Office, P.O. Box
2327, Arlington, VA 22202, on

May 8, 2002

(Date)

Joseph J. Mallon
Joseph J. Mallon, Reg. No. 39,287

RECEIVED

MAY 20 2002

TC 1700

TRANSMITTAL LETTER

United States Patent and Trademark Office
P.O. Box 2327
Arlington, VA 22202

ATTENTION: APPLICATION BRANCH

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement.
- (X) A PTO Form 1449 with Forty-Six (46) references.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

Joseph J. Mallon
Joseph J. Mallon
Registration No. 39,287
Attorney of Record

) Group Art Unit: 1762

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: United States Patent and Trademark Office, P.O. Box 2327, Arlington, VA 22202, on

May 8, 2002
(Date)

Joseph J. Mallon, Reg. No. 39,287

RECEIVED

5 MAY 20 2002

TC 1700

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Respectfully submitted,

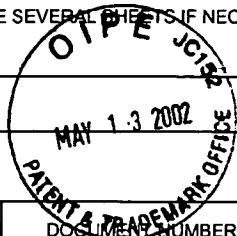
KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: May 8, 2002

By: Joseph J. Mallon
Joseph J. Mallon
Registration No. 39,287
Attorney of Record
620 Newport Center Drive
Sixteenth Floor
Newport Beach, CA 92660
(619) 235-8550

FORM PT, D-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. ASMEX.291A	APPLICATION NO. 10/074,563
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (USE SEVERAL SHEETS IF NECESSARY)		APPLICANT Todd et al.	
		FILING DATE February 11, 2002	GROUP 1762

RECEIVED
MAY 20 2002
TC 1700



U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
	4,363,828	12/14/82	Brodsky et al.			
	4,495,218	1/22/85	Azuma et al.			
	4,585,671	4/29/86	Kitagawa et al.			
	4,684,542	8/4/87	Jasinski et al.			
	5,227,329	7/13/93	Kobayashi et al.			
	5,607,724	3/4/97	Beinglass et al.			
	5,614,257	3/25/97	Beinglass et al.			
	5,648,293	7/15/97	Hayama et al.			
	5,656,531	8/12/97	Thakur et al.			
	5,695,819	12/9/97	Beinglass et al.			
	5,700,520	12/23/97	Beinglass et al.			
	5,786,027	7/28/98	Rolfson			
	5,789,030	8/4/98	Rolfson			
	5,837,580	11/17/98	Thakur et al.			
	5,874,129	2/23/99	Beinglass et al.			
	5,876,797	3/2/99	Beinglass et al.			
	5,885,869	3/23/99	Tumer et al.			
	6,027,705	2/22/00	Kitsuno et al.			11/30/98
	6,083,810	7/4/00	Obeng et al.			12/5/96
	6,197,694 B1	3/6/01	Beinglass			7/31/96

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	57209810 A	12/23/82	Japan			Abstract	
	59078918 A	5/8/84	Japan			Abstract	
	59078919 A	5/8/84	Japan			Abstract	

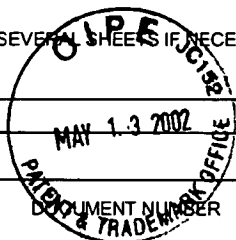
EXAMINER

DATE CONSIDERED

*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

FORM PTQ-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. ASMEX.291A	APPLICATION NO. 10/074,563
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (USE SEVERAL SHEETS IF NECESSARY)		APPLICANT Todd et al.	
		FILING DATE February 11, 2002	GROUP 1762

RECEIVED
MAY 20 2002
TC 1700



FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	60043485 A	3/8/85	Japan			Abstract	
	61153277 A	7/11/86	Japan			Abstract	
	62076612 A	4/8/87	Japan			Abstract	
	63003414 A	1/8/88	Japan			Abstract	
	63003463 A	1/8/88	Japan			Abstract	
	01217956 A	8/31/89	Japan			Abstract	
	01268064 A	10/25/89	Japan			Abstract	
	02155225 A	6/14/90	Japan			Abstract	
	03091239 A	4/16/91	Japan			Abstract	
	03185817 A	8/13/91	Japan			Abstract	
	03187215 A	8/15/91	Japan			Abstract	
	03292741 A	12/24/91	Japan			Abstract	
	04323834 A	11/13/92	Japan			Abstract	
	05021378 A	1/29/93	Japan			Abstract	
	05062911 A	3/12/93	Japan			Abstract	
	07249618 A	9/26/95	Japan			Abstract	
	08242006 A	9/17/96	Japan			Abstract	
	S60-43485	3/8/85	Japan (Patent Disclosure)			X	
	H 02-155225	6/14/90	Japan (Patent Disclosure)			X	
	H3-185817	8/13/91	Japan (Patent Disclosure)			X	
	H3-187215	8/15/91	Japan (Patent Disclosure)			X	
	H3-91239	4/16/91	Japan (Patent Disclosure)			X	
	H5-62911	3/12/93	Japan (Patent Disclosure)			X	

S:\DOCS\JOM\JOM-3155.DOC:ats
050702

EXAMINER	DATE CONSIDERED
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	